FORM PTO 1449 (modified)			ATTY DOCKET NO. APPLICATION NO. 03500.017988.		10/551,112			
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(Use several sheets if necessary)			Susumu Yasuda,  ALING DATE  September 28, 2005			GROUP 2858		
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·	Riehl, P. S., "Microsystems for Electrostatic Sensing", Dissertation, Nov. 2002, pp. 1-8, 32-40, 79-84.							
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\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

Sheet	4	~£	4
Sheet	7	of	7